

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application

Inventor(s): Michel Puech

Appl. No.: 10/516,457

Confirm. No.: 2874

Filed: December 3, 2004

Title: HEATING JACKET FOR PLASMA
ETCHING REACTOR, AND ETCHING
METHOD USING SAME

PATENT APPLICATION

Art Unit: 1716

Examiner: Jeffrie R. Lund

Customer No. 23910

REQUEST FOR CONTINUED EXAMINATION UNDER 37 C.F.R. § 1.114

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This REQUEST FOR CONTINUED EXAMINATION (RCE) and REPLY is in response to the Final Office Action mailed March 18, 2010, and the Interview Summary mailed July 21, 2010. A Petition for Extension of Time is submitted herewith, together with the appropriate fee.

Amendments to the Claims begin on Page 2.

Summary of the Interview begins on Page 7.

Remarks begin on Page 8.